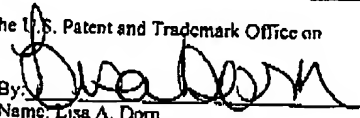


SEP 19 2006

S/N 10/804,610

PATENTIN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	KITAOKA, ET AL.	Examiner:	TU TU V. HO
Serial No.:	10/804,610	Group Art Unit:	2818
Filed:	MARCH 18, 2004	Docket No.:	10873.1420US01
Title:	METHOD OF MANUFACTURING GROUP III NITRIDE SUBSTRATE AND SEMICONDUCTOR DEVICE		

CERTIFICATE UNDER 37 CFR 1.6(d):I hereby certify that this paper is being transmitted by facsimile to the U.S. Patent and Trademark Office on  
September 19, 2006.By:   
Name: Lisa A. DornAMENDMENT UNDER 37 C.F.R. 81.111

Mail Stop: AMENDMENT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Dear Sir:

In response to the non-final Office Action mailed June 22, 2006, please amend the  
above-identified application as follows.

Amendments to the Claims are reflected in the Listing of Claims that begins on  
page 2 of this paper.

Remarks begin on page 11 of this paper.

09/20/2006 TL0111 00000057 503478 10004610

01 FC:1201 200.00 DA  
02 FC:1202 600.00 DA